OMB Control No. 0694-0119 Expiration Date: April 2013

DEFENSE INDUSTRIAL BASE ASSESSMENT: U.S. Infrastructure for Underwater Acoustic Transduction Systems

Company Survey



SCOPE OF ASSESSMENT

The Bureau of Industry and Security (BIS), Office of Technology Evaluation (OTE), in cooperation with the Department of the Navy, Office of Naval Research (ONR), is conducting an assessment of the U.S. Underwater Acoustics Transduction industry. The purpose of this assessment is to analyze the health and competitiveness of the industry and to develop recommendations to ensure the ability of the industry to support Navy missions and programs.

RESPONSE TO THIS SURVEY IS REQUIRED BY LAW

A response to this survey is required by law (50 U.S.C. app. Sec. 2155). Failure to respond can result in a maximum fine of \$10,000, imprisonment of up to one year, or both. Information furnished herewith is deemed confidential and will not be published or disclosed except in accordance with Section 705 of the Defense Production Act of 1950, as amended (50 U.S.C App. Sec. 2155). Section 705 prohibits the publication or disclosure of this information unless the President determines that its withholding is contrary to the national defense. Information will not be shared with any non-government entity, other than in aggregate form. The information will be protected pursuant to the appropriate exemptions from disclosure under the Freedom of Information Act (FOIA), should it be the subject of a FOIA request.

Not withstanding any other provision of law, no person is required to respond to nor shall a person be subject to a penalty for failure to comply with a collection of information subject to the requirements of the Paperwork Reduction Act unless that collection of information displays a currently valid OMB Control Number.

BURDEN ESTIMATE AND REQUEST FOR COMMENT

Public reporting burden for this collection of information is estimated to average 14 hours per response, including the time for reviewing instructions, searching existing data sources, gathering and maintaining the data needed, and completing and reviewing the collection of information. Send comments regarding this burden estimate or any other aspect of this collection of information to BIS Information Collection Officer, Room 6883, Bureau of Industry and Security, U.S. Department of Commerce, Washington, D.C. 20230, and to the Office of Management and Budget, Paperwork Reduction Project (OMB Control No. 0694-0119), Washington, D.C. 20503.

	TABLE OF CONTENTS
<u> </u>	General Instructions
<u>II</u>	Who Must Respond to the Survey
Ш	Definitions
<u>1</u>	Company Information
<u>2</u>	Current Product Types
<u>3</u>	Manufacturing of Piezoelectric Material and Elements for Underwater Acc
<u>4</u>	Capability to Design/Manufacture Underwater Acoustic Transducer Produ
<u>5</u>	Calibration of Underwater Acoutic Transducers and Sonar Systems
<u>6</u>	Transducer/Sub-Assembly Manufacturing - Locations, Processes, Vendo
<u>7</u>	Outsourcing of Transducer Production
<u>8</u>	Competitiveness & Retention of Production Capability
<u>9</u>	Financial Performance
<u>10</u>	Research and Development
<u>11</u>	Employment
<u>12</u>	Certification
<u>12</u>	Certification

oustic Transducers
ioto
ıcts
rs
19
duction Act

Sec	tion General Instructions
Α.	Your company is required to complete this survey using an Excel template, which can be downloaded from the BIS website: http://www.bis.doc.gov/underwater_acoustics/index.htm . At your request, BIS staff will e-mail the Excel survey template directly to your company. For your convenience, a PDF version of the survey is available on the BIS website to aid internal data collection. DO version of your company's response to BIS.
В.	Respond to every question. Surveys that are not fully completed will be returned for completion. Use comment boxes to provide any information to supplement responses provided in the survey form. Make sure to record a complete answer in the cell provided, even if the cell does not appear to expand to fit all the information. DO NOT COPY AND PASTE RESPONSES WITHIN THIS SURVEY. Survey inputs should be made manually, by typing in responses or by use of a drop-down menu. The use of copy and paste can disrupt the data collection process. If your survey response is corrupted as a result of copy and paste responses, a new survey will be sent to you for immediate completion.
	Do not disclose any classified relationships in this survey form. However, aggregated financials, employment, R&D expenditures, etc. are permitted.
D.	Questions related to this survey should be directed to: Matthew Sigmund, 202-482-0634 - matthew.sigmund@bis.doc.gov; Laura DeMaria, 202-482-7804 - laura.demaria@bis.doc.gov; or Mark Crawford, 202-482-8239 - mark.crawford@bis.doc.gov.
E.	If information is not available from your records in the form requested, contact our office to see if you may furnish estimates.
F.	Upon completion, review and certification of the survey, transmit the survey via e-mail to: underwater_acoustics@bis.doc.gov.
	For letter correspondence to the Office of Technology Evaluation (OTE), please write to:
G.	Brad Botwin, Director, Industrial Studies Office of Technology Evaluation, Room 1093 U.S. Department of Commerce 1401 Constitution Avenue, NW Washington, DC 20230 Please do not submit completed surveys to this address; all surveys must be submitted electronically.
	in loads at the satisfic completed surveys to this address, all surveys must be submitted electromedily.
	BUSINESS CONFIDENTIAL - Per Section 705(d) of the Defense Production Act

Sec	tion III Who Must Respond							
Α.	Has your company manufactured underwater transducers and/or sonar systems from 2008-2012?							
В.	Has your company directly or indirectly supplied the United States Navy underwater transducers and/or sonar systems from 2008-2012?							
C.	Has your company produced and/or assembled materials or sub-assembly components for underwater transducers and/or sonar systems from 2008-2012?							
D.	Has your company designed underwater transducers and/or sonar systems from 2008-2012?							
	Exemption From Survey							
desi to co	Exemption From Survey If your organization was not engaged design, manufacturing, and/or research activities in the past 10 years that can support the design or production of materials, parts, or subsystems used in underwater acoustic transducers, it may be exempt from having to complete this survey. Please call one of the contacts listed in General Instruction "D" for a determination as to whether your organization must complete the survey.							
Co	omments:							

Section - Definitions	Definitions
ACOMMS	Short for Acoustic Communications. An underwater acoustic system designed to communicate (transmit or receive) acoustical data via an acoustic medium (water or air).
Acoustic Vector Sensor	A device that concurrently measures acoustic pressure and acoustic particle velocity for the purpose of estimating intensity and direction of propagation of sound at a point in an acoustic field.
Active SONAR	An underwater acoustic system relying on both a user transmitted probe signal and the subsequent detection of returning acoustic signals.
Air-Deployed Sonar Systems	Any transducer-based system used for underwater acoustic signal generation or detection and installed o or deployed from aircraft.
Applied Research	Research for the purpose of applying knowledge or technologies to improve specific problems, devices, methods, or systems. Applied research often has a known potential application.
Basic Research	Research resulting in new knowledge or improved understanding of subject area. Such research may also result in new discovery or invention of ideas, methods or devices.
Basic Research Underwater Acoustic Systems	Any transducer-based system or subsystem components used in basic research and/or testing for underwater acoustic signal generation or detection.
Calibration	The process of testing a tranducer to determine its performance including but not limiting to its transmit or receive sensitivity, impedance in water, directional factor, and electroacoustic efficiency.
Calibration Facilities	Specialized facilities designed for measuring various transducer system responses to specific inputs (acoustic, shakers, signal telemetry, etc).
Ceramic	Any piezoelectric, polycrystalline material based on ferroelectric oxides, such as lead zirconate titanate (PZT) ceramics.
Command Organization	Primary military organization (e.g., NAVSEA, NAVAIR, SPAWAR, etc).
Company	A for profit organization including sole proprietoryship, partnership, company, or corporation.
Division Facilities	Specialized facilities under the direction of a division within a larger command organization.
Educational Institution	Any institution providing college-level courses for academic credit.
Educational Program	A combination of courses from an educational institution leading to a certificate or degree.
Electrode Adhesion	The degree of adhesion of the electrode (e.g. silver, nickel, etc.) to the piezoelement
Electro-Dynamic Actuators and Force Drivers	Piezoelectric and other electromechanical actuators with the prinicple functioin of delivering a force or displacement as opposed to the radiation of sound.
Environmental Parameters	Environmental parameters influencing acoustic propagation, e.g., temperature, pressure, density, bulk modulus, shear speed, attenuation, salinity, sound speed, etc.
Environmentally Controlled Facilities	Specialized measurement facilities in enclosed areas capable of manipulating environmental factors (e.g. temperature, pressure, etc).
Facility	A physical space for performing specific work or activity.
Institutional Facility	A specialized design/manufacturing facility directly managed/owned by an educational institution.
Integrated Electronics	The collection of electronic components on an electronic circuit board, membrane or other medium.
Lake/Ocean Facilities	Specialized measurement facilities in lakes or open ocean ranges (e.g., Lake Pend Oreille, AUTEC, etc).
Magnetics Design	The steps, procedures, and results associated with designing inductive tuning elements and impedance (step-up and step-down) transformers that are often necessary in an acoustic transducer subsystem.
Magnetostrictive materials	Ferromagnetic materials alter in shape when subject to magnetization.

Manufacturing Standards	The standards and expectations associated with quality and tolerances associated with a particular manufacturing process.
Material Bonding	The bonding of two materials.
National Security	A collective term encompassing national defense and homeland security, including the military, civilian intelligence agencies, border security, etc.
National Security Systems	Any transducer-based system that utilizes underwater acoustics for purposes of national security.
Oceanographic Systems:	Underwater acoustic systems designed to measure oceanographic features, e.g., acoustic Doppler profilers, hydrographic systems, bathymetric systems, etc.
Passive SONAR	An underwater acoustic (SOund, Navigation, And Ranging) system used to detect acoustic signals with receivers only (the system does not genearate a probing acoustical signal).
Piezoceramic element	A piezoelectric ceramic element (such as a bar, plate, cylinder, etc.) made from a ceramic based compositioin exhibiting piezoelectric properties.
Piezocrystal element	A piezoelectric crystal element (such as a bar, plate, disk, etc.) made from a crystaline composition (such as quartz or PMN-PT single crystal) exhibiting piezoelectric properties.
Piezoelectric	The physical property of a material that converts mechanical energy into electrical energy (electromechanical piezoelectric effect) or mechanical energy into electrical energy (mechano-electric piezoelectric effect).
Potting	The process of enclosing (or so called potting) an acoustic transducer with a waterproof solid layer, usuall comprised of polyurethane, rubber, or plastic.
Process Control	Methods and controlls associated with manufacturing (or processing) piezoelectric materials and/or transducers.
R&D	Research and Development: All steps associated with the research and/or development of a product.
RDT&E	Research, Development, Test and Evaluation.
Single Crystal	Any relaxor-based, piezoelectric single crystal material, such as lead magnesium niobate-lead titanate (PMN-PT).
Sonar Transducer Relability Improvement Program (STRIP)	A US Navy program with emphasis on reliability improvement of sonar transducers and support of device used in the Fleet (currently administered by NAVSEA/NUWC).
Sub-assembly	Any component of a system, which may or may not work independently.
Submarine Sonar Systems	Any transducer-based system used for underwater acoustic signal generation or detection and installed or or deployed from submarines.
Surface Ship Sonar Systems	Any transducer-based system used for underwater acoustic signal generation or detection and installed or deployed from surface vessels.
Technical Personnel/Engineering Force	Technically trained/educated workforce directly involved with aspects of design and/or manufacturing of transducer products and SONAR systems.
Telemetry	Systems and subsystem components that involve the transmission of acoustic signals by wire, air, or wate Such systems may include conversion of signals to higher carrier frequencies or to different forms of energy such as electromagnetic, light, mechanical or acoustical.
Tons	2000 pounds (0.907 metric ton)
Transducer	Any device that converts acoustical energy into electrical energy, and vice-versa.
Transducer Design	The design and description of acoustical transducers (projectors and recevers) and related performance pedictions or estimates
Transducer Manufacturing	The building or production of acoustic transducers with commercialization as the goal or end purpose.
Transducer Products	Any transducer device or subsystem comprising an electroacoustic transducer that may be commercially available or made available to a navy or research application or demonstration.
Underwater Acoustic Communication Systems	Any transducer-based system used for underwater acoustic communications.
Underwater Imaging or Scanning Systems	Any transducer-based system used for underwater scanning applications.
Underwater Imaging or Scanning Systems	Any transducer-based system used for underwater scanning applications.

300	ction 1	Company Inform	nation	
	Company Name			
^	Business Unit/Division Name (if applicable)			
	Street Address			
	City			
Α.	State			
	Zip Code			
	Phone Number			
	Fax Number			
	Website			
	Point of Contact(s) regarding this	s survey:		
_	Name	Title	E-mail	Phone Number
B.				
	Comments:			
	BUSINESS	CONFIDENTIAL - Per Section	705(d) of the Defense Produ	ction Act

Sec	tion	1.b	C	ompany Ownership Informa	tion			
		company is headquartered in:						
		company is:						
A.		Parent Company Name		Address	City	State/Province	Country	
,	<u> </u>	company is Public/Private: parent company is Public/Private:			_			
	Fron	n 2008-2012, has one or more foreign ent or more of stockholder voting shar		I nts invested, directly or indirect	l tly, in your company	and control 5		
	If yo	u answered "Yes," please explain the t	 	estment and identify the foreign	government(s).			
_	L.,	Type of In	vestment			Foreign Government		
В.	1.							
	2.							
	3.							
	4.							
	5.							
		Comments:						
		BUSINESS	CONFIDE	NTIAL - Per Section 705(d) o	of the Defense Pro	duction Act		

	tion 1.c Co	mpany St	ucture and	Operation	s						
	State the number of underwater transducer or										
			008		009		010 of Facilitie	20	11	2012 - 1	Estimate
				T				<u> </u>			
	Facility Function	Inside U.S.	Outside U.S.	Inside U.S.	Outside U.S.	Inside U.S.	Outside U.S.	Inside U.S.	Outside U.S.	Inside U.S.	Outside U.S.
	Danian	0.0.	0.0.	0.0.	0.0.	0.0.	0.0.		0.0.		0.0.
	Design			_							
	Sonar System Fabrication Transducer System Fabrication			-							
	Indicate the number of underwater sonar syst	em fabrica	tion facilitie	es that you	company ci	urrently ope	erates with s	security clear	ances:		
	Indicate the number of underwater transducer Enter the CAGE numbers for each cleared faci				CAGE numb				clearances	s:	
		ility below -	#1:	Enter the		ers for eac	n cleared la	icility - #2:			
	CAGE 1:				CAGE 1:						
	CAGE 2:				CAGE 2:						
	CAGE 4:				CAGE 3: CAGE 4:	_					
	CAGE 4:				CAGE 4:	_					
	Indicate the number of underwater transducer	and conar	cyctom fabri	cation facili	tion that you	r company	currently on	oratoc with c	ocurity clos	rancos:	
	Enter the CAGE numbers for each cleared faci				CAGE numb				ecurity cied	ilances.	
	CAGE 1:	, 50.011			CAGE 1:	1.5.0.00	Sicurca iu	,			
	CAGE 2:				CAGE 2:						
	CAGE 3:				CAGE 3:						
	CAGE 4:				CAGE 4:						
	Indicate the number of underwater transducer	and sonar	system fabri	cation facili	ties that you	r company	currently op	erates with s	ecurity clea	arances:	
	Enter the CAGE numbers for each cleared faci	lity below -	#5:	Enter the	CAGE numb	ers for eac	h cleared fa	cility - #6:			
	CAGE 1:				CAGE 1:						
	CAGE 2:				CAGE 2:						
						_					
	CAGE 3:				CAGE 3:						
	CAGE 4:				CAGE 3: CAGE 4:						
	CAGE 4:										
	CAGE 4: Comments:		serves throu	ugh the pro	CAGE 4:	ign and/or	fabrication s	services for u	nderwater t	ransducer an	nd sonar
	CAGE 4:		serves throu	ugh the pro	CAGE 4:	ign and/or	fabrication s	services for u	nderwater t	ransducer an	ıd sonar
	CAGE 4: Comments: Please specify the technology sectors that you	r company	serves throu	1	CAGE 4:	_	fabrication s	services for u	nderwater t	ransducer an	
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities >	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
_	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems Underwater Acoustic Communication Systems Underwater Scanning Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Surface Ship Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems Underwater Scanning Systems UUV/AUV Acoustic Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems Underwater Acoustic Communication Systems Underwater Scanning Systems UndVIAVIA VACOUSTIC Systems Geophysical Exploration Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems Underwater Acoustic Communication Systems Underwater Scanning Systems Hydrographic Survey Systems Hydrographic Survey Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems Underwater Acoustic Communication Systems Underwater Scanning Systems UndVIAVIA VACOUSTIC Systems Geophysical Exploration Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems Underwater Acoustic Communication Systems UUV/AUV Acoustic Systems UUV/AUV Acoustic Systems Geophysical Exploration Systems Hydrographic Survey Systems Object Detection Systems	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems Underwater Acoustic Communication Systems Underwater Scanning Systems UDV/AUV Acoustic Systems Geophysical Exploration Systems Hydrographic Survey Systems Object Detection Systems Object Detection Systems Other National Security Systems (Specify)	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems Underwater Acoustic Communication Systems UUV/AUV Acoustic Systems UUV/AUV Acoustic Systems Hydrographic Survey Systems Object Detection Systems Object Detection Systems Other National Security Systems (Specify)	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems Submarine Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems Underwater Acoustic Communication Systems UNDAIV Acoustic Systems Geophysical Exploration Systems Hydrographic Survey Systems Object Detection Systems Other National Security Systems (Specify) Other National Security Systems (Specify) Other (Specify)	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		
	CAGE 4: Comments: Please specify the technology sectors that you system products: Company Capabilities > Air-Deployed Sonar Systems Basic Research Underwater Acoustic Systems Distributed Netted Systems Object Detection Systems Submarine Sonar Systems Surface Ship Sonar Systems Surface Ship Sonar Systems Underwater Acoustic Communication Systems Underwater Scanning Systems Underwater Scanning Systems Underwater Scanning Systems Hydrographic Survey Systems Geophysical Exploration Systems Hydrographic Survey Systems Object Detection Systems Other National Security Systems (Specify) Other National Security Systems (Specify)	r company		1	CAGE 4: vision of des	_		services for u	nderwater t		

tion 2.a			Current Produ	ct Types -	o.S. Custo	mers			
	State whether your isted below . Resp	company designs and/or manufact ond to each cell.	urers underwate	er acoustics	s, vibration,	or sonar systems	-related produ	ucts for each class	of U.S. customer
	Product Type		DoD/National Security	Oil Industry	Fishing	Hydrographic Surveying	Non-DOD Object Detection	Oceanographic	Other (specify)
Ē	Piezoceramics for transducers								
С	crystals, polymers,	<u> </u>							
		aterials for transducers							
A. T	Fransducers based han ceramics (e.g.	on piezoceramic materials on piezoelectric materials other , piezocrystals such as PMN-PT or s, polymers, or other)							
Ī	Fransducers based	on magnetostrictive materials							
-	Telemetry for trans	<u> </u>							
F		s for sonar systems (encapsulants,							
c	Other Underwater \	/ibration Sensors							
	Other (specify)								
C									
II p	Other (specify) f your company cu percentage of each	rrently manufactures and/or designs business line that utilize each of th on is not applicable to your compan	e material type:	s below. In					
C If	Other (specify) f your company cu percentage of each	business line that utilize each of th	e material type:	s below. In			Non-DOD Object		plicable. Select
C If	Other (specify) f your company cu percentage of each 'N.A." if this question	business line that utilize each of th	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	ch type of U.S Non-DOD	5. customer, as ap	plicable. Select
C If	Other (specify) f your company cu percentage of each	business line that utilize each of the property of the propert	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	Non-DOD Object	5. customer, as ap	
III P	Other (specify) If your company cu percentage of each N.A." if this questic Piezoceramic Transducers	business line that utilize each of the in is not applicable to your company. Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	Non-DOD Object	5. customer, as ap	plicable. Select
C	Other (specify) f your company cu percentage of each N.A." if this question Piezoceramic Transducers	business line that utilize each of the in is not applicable to your company. Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	Non-DOD Object	5. customer, as ap	plicable. Select
III P	Other (specify) If your company cu percentage of each N.A." if this questic Piezoceramic Transducers	business line that utilize each of the process of t	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	Non-DOD Object	5. customer, as ap	plicable. Select
III P	Other (specify) If your company cu percentage of each N.A." if this questic Piezoceramic Transducers	business line that utilize each of the process of t	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	Non-DOD Object	5. customer, as ap	plicable. Select
C	Other (specify) If your company cu percentage of each N.A." if this questic Piezoceramic Transducers	business line that utilize each of the in is not applicable to your company. Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Other materials (e.g., polymers)	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	Non-DOD Object	5. customer, as ap	plicable. Select
B	Other (specify) If your company cubercentage of each N.A." if this question Piezoceramic Transducers Non-Piezoceramic Transducers Other Underwater	business line that utilize each of the is not applicable to your company. Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Other materials (e.g., polymers) Using PZT ceramic materials	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	Non-DOD Object	5. customer, as ap	plicable. Select
С Н р п п	Other (specify) f your company cu percentage of each N.A." if this questic Piezoceramic Transducers Non-Piezoceramic Transducers	business line that utilize each of the is not applicable to your company. Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Other materials (e.g., polymers) Using PZT ceramic materials Using non-PZT ceramic materials	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	Non-DOD Object	5. customer, as ap	plicable. Select
B. 1	Other (specify) If your company cubercentage of each N.A." if this question Piezoceramic Transducers Non-Piezoceramic Transducers Other Underwater	business line that utilize each of the in is not applicable to your company. Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Other materials (e.g., polymers) Using PZT ceramic materials Using non-PZT ceramic materials Using piezocrystal materials Using magnetostrictive materials	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	Non-DOD Object	5. customer, as ap	plicable. Select
- C	Other (specify) If your company cubercentage of each N.A." if this question Piezoceramic Transducers Non-Piezoceramic Transducers Other Underwater	business line that utilize each of the in is not applicable to your company. Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Other materials (e.g., polymers) Using PZT ceramic materials Using non-PZT ceramic materials Using piezocrystal materials	e material types y. Respond to DoD/National	s below. In each cell. Oil	dicate this p	percentage for each	Non-DOD Object	5. customer, as ap	plicable. Select

	tion 2.b		Current Product T	ypes - Noi	า-U.S. Cu	stomers			
		company designs and/or manufacture elow . Respond to each cell.	ers underwater acousti	cs, vibratio	n, or sona	ır systems-relate	ed products fo	r each class of No	n-U.S.
	Product Type		Non-U.S. Defense/ National Security	Oil Industry	Fishing	Hydrographic Surveying	Non-DOD Object Detection	Oceanographic	Other (specify)
	Piezoceramics for transducers								
	Other piezoelectric materials for transducers (e.g., crystals, polymers, etc.)								
	Magnetostrictive ma	terials for transducers							
Α.		on piezoceramic materials							
	than ceramics (e.g.,	on non-piezoceramic materials other piezocrystals such as PMN-PT or , polymers, or other)							
	Transducers based	on magnetostrictive materials							
	Telemetry for transd	ucers							
	Packaging materials connectors, other pa	s for sonar systems (encapsulants, arts)							
	Other Underwater V	ibration Sensors							
	Other (specify) Other (specify)								
		of the material types below. Indicate ompany. Respond to each cell.				ers as indicated customer, as a	applicable. Se		
		ompany. Respond to each cell.	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
	applicable to your or	Product Type Using PZT ceramic materials	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
В.	applicable to your co	Product Type Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
3.	applicable to your control of the property of	Dempany. Respond to each cell. Product Type Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
3.	applicable to your control of the property of	Dempany. Respond to each cell. Product Type Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals)	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
3.	applicable to your control of the property of	Dempany. Respond to each cell. Product Type Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
3.	applicable to your control of the property of	Dempany. Respond to each cell. Product Type Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Using materials (e.g., polymers)	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
3.	applicable to your control of the property of	Dempany. Respond to each cell. Product Type Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Using materials (e.g., polymers) Using PZT ceramic materials	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
В.	applicable to your control of the property of	Dempany. Respond to each cell. Product Type Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Using materials (e.g., polymers) Using PZT ceramic materials Using non-PZT ceramic materials	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
3.	applicable to your control of the property of	Dempany. Respond to each cell. Product Type Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Using materials (e.g., polymers) Using PZT ceramic materials Using non-PZT ceramic materials Using piezocrystal materials	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
В.	applicable to your control of the property of	Dempany. Respond to each cell. Product Type Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Using materials (e.g., polymers) Using PZT ceramic materials Using non-PZT ceramic materials Using piezocrystal materials Using magnetostrictive materials	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not
В.	applicable to your control of the policy of	Dempany. Respond to each cell. Product Type Using PZT ceramic materials (Lead-Zirconium-Titanate) Using non-PZT ceramic materials (Barium-Titanate or other) Using piezocrystal materials (PMN-PT or other relaxor type single crystals) Using magnetostrictive materials Using materials (e.g., polymers) Using PZT ceramic materials Using non-PZT ceramic materials Using piezocrystal materials Using magnetostrictive materials	this percentage for ea	och type of	Non-U.S.	customer, as a	Non-DOD Object	elect "N.A." if this o	question is not

Sec	tion 2	2.c	Non-U.S. Defense/Na	tional Security Customers	
	If you provi	ur company indicated that it supplied any ide the names of companies/organization	of the product types listens, their location, and a d	ed in the previous section to lescription of the products s	Non-U.S. Defense/National Security-related customers, then upplied.
		Customer Name	City	Country	Product Description
	1.				
	2.				
	3.				
A.	4.				
	5.				
	6.				
	7.				
	8.				
	9.				
	10.				
		Comments:			
		BUSIN	ESS CONFIDENTIAL - F	Per Section 705(d) of the D	Defense Production Act

Sect	tion 3.b Manufacturing of Pie	oelectric Material	and Elements fo	r Underwater A	coustic Transc	lucers					
	State whether your company can design and/or manufacture transduction materials for underwater acoustic transducers for each technical property designated below. f so, indicate the percentate (%) for DoD/National Security, bio-medical, or commercial (e.g., fishing, oil industry, etc.)."										
	Technical Property	Passive SONAR Sensor	Active SONAR Element	Mine-Hunting	Doppler Profiling	Side-Scan SONAR	Acoustic Comms				
ı	Capable of operation in surf zone (< 20m)										
- 1	Capable of operation in littorals (< 200m)										
	Capable of operation in deep ocean (> 3000m)										
	Operational below 500 Hz										
ო. ֈ	Operational between 500 Hz - 2 kHz										
	Operational between 2 kHz - 10 kHz										
	Operational between 10 kHz - 50 kHz										
	Operational between 50 kHz - 2 MHz										
	Omnidirectional		+	 			+				
	Directional		+	 							
	Power/Energy requirements										
	Size, Weight, or Packaging Constraints		+								
	Capable of measuring vector acoustic field										
	Other capabilities										
	Specify which geometries your company consider	ers as unique or spe	ecial canabilties of	vour manufactu	ring process:						
	Specify which geometries your company consider			T T T T T T T T T T T T T T T T T T T		1					
	Type of Geometry	Unique/Special Capability?	Maximum Diam centimeters)	ieter (in	Description Unique/Spe Capabilities	cial					
В. [Bar										
	Plates										
	Hollow Cylinders										
ı	Tubes										
	Other (specify)										
	Other (specify)										
	Does your company have the capability to do high-field testing of ceramics?										
	If "Yes," what is the maximum voltage you high-field (> 1 kvolts/cm) testing can achieve? Provide your answer in kilovolts (kV).										
	If "Yes," what is the minimum electrode separation your high-field testing can achieve? Provide your answer in centimeters.										
	Identify the types of inventory of manufacturing materials and/or finished piezoelectric material products that your company maintains.										
	On average, what is the average supply level of	•	•	•	ory?						
	On average, what is the average supply level of	manufacturing mate	erials kept in inven	tory?							
	On average, what is the average supply level of manufacturing materials kept in inventory? Does your company manufacture its own If "Yes" state your production capacity and the locations of your										
	piezoelectric powders? Total Number of Production Facilities		production facilitie Annual Production		S. Locations						

	Production Facility Name			City		
E.						
	State the percentage of materials produced annu	ally that is attributed	d to your Non-U.S	. piezoelect+C17ric powder mai	nufacturing facilities	
	State the percentage of the piezoelectric material company-owned Non-U.S. facilities)	s that your company	y uses in any give	n year that is imported (excludin	ng production from	
	State the number of Non-U.S. suppliers from which	ch you currently imp	ort piezoelectric r	materials		
	Identify the locations of the production facilities for	or your company's N	on-U.S. Suppliers	of piezoelectric materials.		
	Production Facility Owner	Production Facility I	Name	City	Country	
F.						
	Comments:					
G.	entify the procedures your company routinely uses to insure that piezoceramic materials identified below meet U.S. Navy-type specifications r ceramics. Select all practices that apply.					
	Material Type			Testing Processes Utilize	d for Designated Materia	als
				-		
	Navy Type I			Test received samples for impe to previous products for consist		
	Navy Type II			Evaluate samples received per size, capacitance, and/or dissip		
	Navy Type III			Rely on suppliers statements/rematerials are equivalent	epresentations that their	
	Navy Type IV			Measure the piezoelectric prop materials according to IEEE sta piezoelectricity	erties of sample andards No 176 on	
	Navy Type V			Measure the piezoelectric prop methods	erties according to other	
	Navy Type VI			Measure completed transducer specs	s to ensure they meet	
	Polyvinylidene flouride (PVDF)			Other (describe below)		
	Single Crystal PMN-PT					
	Single Crystal PIN-PMN-PT					
	Galfenol					
	Terfenol-D					
	Lithium Sulfate					
	Comments:					
Н.	Does your company have the capability to design	and develop impro	ved piezoceramic	es?		
	Comments:					
	BUSINES	S CONFIDENTIAL	- Per Section 70	5(d) of the Defense Productio	n Act	

Sec	tion 3.c Capacity	Utilization Rate f	or Materials Produc	ction							
	Report your company's average manu.Sbased facilities for 2008-2012.	ufacturing capacity	utilization rate for tra	ansduction materials	(ceramics, crystals	, etc) at your					
A.		2008	2009	2010	2011	2012 Estimated					
	Utilization Rate										
В.	State the actual transduction material manufacturing facilities in 2011.	elements possible	per month at your U	J.Sbased							
	Indicate the number of transduction n	naterial elements p	roduced at your facil	lities for each type o	f geometry in 2011.						
	Type of Geometry			Number of	Elements						
			Piezeo-Ceramics	Single Crystals	Other						
	Tubes				-						
C.	Disks					-					
	Rings										
	Plates					-					
	Hemispheres										
	Made from Ceramics					-					
	Single Crystals										
	Other (specify)		-								
-	Other (specify)										
	State the maximum number of transduction material elements possible per month at your U.S										
D.	based manufacturing facilities in 2011.										
	How long would it take (in months) to	achieve this maxin	num capacity rate?								
E.	Indicate whether all of your transducti through 2015. If "No," explain below.	on material manufa	acturing facilities will	be operating							
					1						
F.	In what year did your company achiev transduction material elements per m			Year							
				Max. Number							
G.	What are the critical issues (technology manufacture at the maximum utilization to the maximum utilization)		force, etc) needed to	maintain this capat	oility at your product	ion facilities to					
Н.	Does your company have a long-term "Yes," describe below 1) the product				t is produces? If	Yes/No					
	Does your company have a long-term	plan to increase o	r reduce the volume	of production for co	ertain product						
1.	lines? If "Yes," describe below 1) the					Yes/No					
	Do your company's commercial busin materials or products to the military or				ability to supply	Yes/No					
J.	products to the military of	7.36 VOI30: II 16	o, describe triese III								
K.	Do your company's military business materials or products to the commerc					Yes/No					
	Comments:										
	BUSINESS CO	ONFIDENTIAL - Pe	er Section 705(d) of	the Defense Produ	uction Act						

	gn/Manufacture Underwater						21		
State whether your company from 200 technical parameters:	J8-2011 designed and/or mani	utactured und	erwater acou	stic transqu	cers and vir	oration sense	ors with eac	n of the fol	owing
	General Purpose/R&D	Passive SONAR Sensor	Active SONAR Element	Mine- Hunting	Doppler Profiling	Side-Scan SONAR	Acoustic Comms	Other?	Other?
Capable of operation in surf zone (< 2	(Om)			, and the second					
Capable of operation in littorals (< 200	Dm)								
Capable of operation in deep ocean (2	> 3000m)								
Operational below 500 Hz									
A. Operational between 500 Hz - 2 kHz									
Operational between 2 kHz - 10 kHz									
Operational between 10 kHz - 50 kHz									
Operational between 50 kHz - 2 MHz									
Omnidirectional									
Directional									
Power/Energy requirements									
Size, Weight, or Packaging Constrain	ts								
Capable of measuring vector acoustic	field								
Other (indicate)									
Comments:									
	BUSINESS CONFIDENTIAL -	Per Section	705(d) of the	e Defense P	Production	Act			

Sect	tion 4.c Capacity Utilization	n Rate for Transdu	cer Product Produ	ıction							
	Report your company's average manufact products at your U.Sbased facility for 200	uring capacity utiliz			d vibration						
		2008	2009	2010	2011						
A.	Transducer Production Utilization Rate	%	%	%	%						
	Vibration Production Utilization Rate	%	%	%	%						
	State the actual transducer and vibration pranufacturing facility in 2011.	product units per mo	onth (average) at yo	our U.Sbased							
C.	Indicate the number and types of transduc	er and vibration pro	duct units produced	l at your facility in 20	011:						
D.	How long would it take (in weeks) to achieve a maximum capacity rate? Indicate whether all of your underwater transducer and vibration product manufacturing facilities will be operating through 2015. If "No." explain below.										
E.	E. De operating through 2010. If two, explain below.										
F.	In what year did your company achieve its month? Maximum production number ach number of 8-hour shifts operated per day	nieved?	State the	Year Max. Number Number of Shifts Per Day							
G.	What are the critical issues (technology, n at the maximum utilization rate?	naterials, workforce	, access to capital, ε	etc) needed to main	tain this capability						
	Does your company have a long-term plar vibration product lines that it produces? If the reasons for change.										
	Does your company have a long-term plan certain transducer and vibration product lin and 2) the reasons for change.				Yes/No						
	Comments:										
	BUSINESS CONFIDENTI	AL - Per Section 7	05(d) of the Defens	se Production Act							

Sec	tion 4			Transduction M			
		tify your company's top suppliers for piez age lead-time to receive your piezo-cera				e supplier, a description of the product(s)	supplied, and the
	Supplier Name		City	State/Province	Country	Material Type	Average Lead-Time (in Weeks)
	1.						
	2.						
A.	3. 4.						
	5.						
	6.						
	7.						
	8.						
	9.						
	10.						
		Comments:					
_		ur company utilizes non-U.S. suppliers fo able? If "Yes," describe your reasoning				here an equivalent U.Sbased supplier	
B.							
		Comments:					
		BUSINESS	CONFIDENTI	AL - Per Section	705(d) of the De	efense Production Act	

Α.	Report the percentage of your company's U.Sbased underwater transducer and vibration technology design and manufacturing capacity that was utilized to produce national security-	Design	Manufacturin
В.	Indicate the percentage of your company's U.Sbased transducer design and manufacturing capacity that it would be willing to make available for, or otherwise commit to, future national security-related production for underwater acoustics and vibration technologies, assuming fair cost and profit?	Design	Manufacturir
C.	Report the percentage of your company's non-U.S. based transducer design and manufacturing capacity utilized to U.S. produce national security-related products in 2011:	Design	Manufacturir
C	omments:		

Sec	tion 5.b	Division Faci	lities Information							
A.	How many years has your company been involved in transducer calibration?									
	State the number of transducer calib									
		2008	2009	2010	2011	2012				
	Total number of facilities									
B.	Number of lake and/or ocean facilities									
	Number of environmentally controlled facilities									
	Comments:									
		BUSINESS CONFIDE	NTIAL - Per Section 705(d) of the Defense Produc	ction Act					

Name of Facility Street Address City State Usable Usable Usable Depth Proquency Depth Proquency Depth Program	llenges to aining this acility
Name of Facility Street Address City State Usable Usable Usable Usable Usable Usable Usable Frequency Range (in Hz) 1	aining this
Name of Facility Street Address City State Usable Usable Usable Usable Depth Prequency Depth Prequency Depth Presing/Calibration? Testing/Calibration?	aining this
A	
A	
A	
6.	
To	
8. 9. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10. 10.	
10.	
For each lake a 6000 0000000000000000000000000000000	
Note: Only provide Anse grations of physical upgrades. The control of the contr	
1. 0 2. 0 3. 0 4. 0 5. 0 6. 0 7. 0	
2. 0 3. 0 3. 0 4. 0 5. 0 6. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 7. 0 8. 0 8	
B. 4. 0 5. 0 6. 0 7. 0 8. 0 7. 0 8. 0 7. 0 7. 0 7. 0 7	
B. 5. 0 6. 0 7. 7. 0 8. 0 8. 0	
6. 0 7. 0 8. 0	
8. 0	
9. 0	
10. 0	
Identify any other lake and/or ocean facilities that your company operates for testing/calibrating underwater transduction devices.	
Name of Facility Street Address City State Frequency Individual Sensor Scale System Controlled at this Support Staff Status of Facility Mair	lenges to aining this
Usable Length Width Depth State Length State	acility
C	
Comments:	
BUSINESS CONFIDENTIAL - Per Section 705(d) of the Defense Production Act	

Soc	tion 5.d		Current Testing	Calibration Facilities -	Environme	ontally Con	trolled Eac	ilitios						
260			- i		=IIVIIOIIIII	entally Con	troneu Fac	illues						
	Please provide information about environmental	lly controlled facilities	managed by your comp	oany.										
					Physical	Dimensions	(Meters)	Usable	Appropriate for	Appropriate for Full-	Environmental Factors	Number of Technical		Challenges to
	Name of Calibration System	Street Address	City	State	Usable Length	Usable Width	Usable Depth	Frequency Range (in Hz)	Individual Sensor Testing/Calibration?	Scale System Testing/Calibration?	Controlled at this Facility - Select All That Apply	Support Staff Assigned to Facility	Status of Facility Infrastructure	Maintaining this Facility
١,	1.													
A.	2.													
	3.													
	4.													
	5. 6.													
	7													
	8.													
	9.													
	10.													
	Identify any critical and/or recommended updates Note: Only provide descriptions of physical upgr	rades. Do not list cost e	estimates.		asis.									
	Name of Calibration System	Enviro	onmental Parameters Co	ontrolled			Crit	ical Updates		Recommended Updates				
	1.	Ambient Pressure												
	2.	Attenuation												
B.	3.	Bulk Modulous												
	4.	Density												
		Salinity												
		Shear Speed												
		Sound Speed												
	8.	Temperature												
	9.													
	10.													
	Comments:													
				BUSIN	ESS CONF	IDENTIAL -	Per Section	n 705(d) of the D	efense Production Act					

						1
Sec	ction 5.e Capacity Utilization F	Rate - Lake/Ocean F	acilities			
	Indicate your company's average capacity utilization rate a			acilities for 2008-20	12.	
	Name of Facility	2008	2009	2010	2011	2012 Estimated
	1.					
	2.					
A.	3. 4.					
	5.					
	6.					
	7.					
	9.					
	10.					
	State the maximum number of sensor or system calibration	ons possible per mor	nth at each lake/oce	an calibration facili	ties in 2011.	
	Name of Facility	Max Individual Se	nsor Calibrations	Max Indiv	ridual System Ca	librations
	1.					
	3.					
В.	4.					
	5.					
	6.					
	7.					
	9.					
	10.					
	State the actual number of sensor or system calibrations	nassible per menth o	et oogh lekeleesen	aclibration facilities	in 2011	
	Name of Facility	Actual Individu	al Sensor Cals	Actual	Individual Syster	n Cals
	1. 2.					
	3.					
C.	4.					
	5.					
	6.					
	7. 8.					
	9.					
	10.					
	Indicate whether each of your lake/ocean calibration fac	ilities will be operati	ng through 2015. If	"No," explain below.		
	Name of Facility	Yes/No		If No, provide pri	mary reason.	
	1. 2.					
	3.					
D.	4.					
	5.					
	6.					
	7. 8.					
	9.					
	10.					
	Comments:					
	BUSINESS CONFIDEN	ITIAL - Per Section	705(d) of the Defen	se Production Act		

	E.f. Our classification B.									
ection	port your company's average capacity utilization ra	ate - Environmentally Co		ation facilities for ve	pars 2008-2012					
	Name of Facility	2008	2009	2010	2011	2012 Estimated				
1. 2.										
3.										
A. 4. 5.										
6. 7.										
8.										
9. 10.										
	State the maximum number of sensor or system calibrations possible per month at each environmentally controlled calibration facilities in 20									
1.	Name of Facility	Max Individual Se	ensor Calibrations	Max Individual System Calibrations						
2.										
3. B. 4.										
5.										
6. 7.										
8.										
9. 10.										
Sta	te the actual number of sensor or system calibrati	ions possible per month a	t each environment	ally controlled cal	ibration facilitie	s in 2011.				
	Name of Facility	Actual Individu			al Individual Syst					
1.										
2. 3.										
C. 4.										
5. 6.										
7.										
8. 9.										
10.										
Indi	icate whether each of your environmentally con	trolled calibration faciliti	ies will be operating	through 2015. If "N	lo," explain belov	v.				
1	Name of Facility	Yes/No		If No, state the	orimary reason.					
1. 2.										
3. D. 4.										
D. 4. 5.										
6. 7.										
8.										
9. 10.										
110.	Comments:									
	BUSINESS CONF	IDENTIAL - Per Section	705(d) of the Defen	se Production Act						

state whaccorda	hether your company/organization/univer	rsity can test and/or calil		stic transducers i
2015, or	r will you develop this capability by 2015'	?		Capable Throu
	Calibration	Mode of Calibration*	Currently Capable?	2015?
Free Fie Calibrati	eld Voltage Sensitivity (FFVS) Primary ion Methods			
	Conventional / Free Field Reciprocity (Bobber 2.3.1)			
	Two Transducer Reciprocity (Bobber 2.3.2)			
	Self Reciprocity (Bobber 2.3.3) Cylindrical Wave Reciprocity			
	Cylindrical Wave Reciprocity (Bobber			
	₹₁3₁5)Reciprocity - Propagating			
	Wave (Bobber 2.3.6) Coupler Reciprocity (Bobber 2.3.7) Transfer Coupler Reciprocity			
	Transfer Coupler Reciprocity			
	(気が呼鳴 ector Null Method (Bobber eld Valitige Sensitivity (FFVS)			
Seconde				
	Comparison reality and reality			
	Sailtuation (Biobber Sailbration (Bobber Signit Tank Calibration			
	(Robber 2.2.2)			
	Impedance Method Calibrations			
	Small Tank Calibration (Beibber 2.2.3) Impedance Method Calibrations Compliance Controlled (ReliteC&rfa3led			
	Static (Low Static & F@alibration			
	Methods Dunking machine (Soleher & & Rharator			
	e Gradient / Part(Setherbarg-3)			†
Measure	e Gradient / Partisle Velocity () eme _{ph} ree Field Calibration (Bobber			
	Standing Wave Calibration Rigid walled tube			
	CORPRAIN 7 Slow wave			
	tube (Bastyr, Lauchle			
Electrica	al Impedance / Admittance			
Efficiend				
	Direct Method (Bobber 2.14.1) Impedance Method (Bobber 2.14.2)			
Dynamic	c Range - Hydrophone (Bobber 2.15)			-
Linearity	y - Projector and Receiver (Bobber 2.15)			
Equivale	ent Noise Pressure (Bobber 2.16.2)			
Directivi	ity Patterns			
	Far Field Near Field			
	Uniform Radiator			
	Non-uniform Radiator			
	Beam Width			
	Minor Lobe Level			
	Directivity Factor / Index			
Parame	ter Ranges Frequency range and resolution			
	Temperature range			+
	RIGGSHIP 490000 for beam			
	patterns			
	Nominal uncertainty			
Magneti	ic Characteristics	Degree of Accuracy		
	Magnetic orientation Inertial orientation	+/- 1 +/- 5		
	Magnetic orientation	+/- 10		
	Inertial orientation	+/- 15		
Indicate	whether your company can test and/or of	calibrate underwater acc	ouetic transducers in ac	cordance with e
indicate whether your company can test and/or c of the following technical specifications. For each through 2015, or will develop this capability by 20		ch, indicate whether you	r company plans to reta	in this capability
through				Capable Thro
through	hnical Specifications for Projector Calibration	Mode of Calibration*	Currently Capable?	2015?
Tecl Transmi	Calibration it Voltage Response	Mode of Calibration*	Currently Capable?	
Tecl Transmi Transmi	Calibration it Voltage Response it Current Response	Mode of Calibration*	Currently Capable?	
Transmi Transmi Source	Calibration it Voltage Response it Current Response Level Maximum	Mode of Calibration*	Currently Capable?	
Tecl Transmi Transmi	Calibration it Voltage Response it Current Response Level Maximum cy	Mode of Calibration*	Currently Capable?	
Transmi Transmi Source	Calibration it Voltage Response it Current Response Level Maximum		Currently Capable?	
Transmi Transmi Transmi Source Efficience	Calibration it Voltage Response it Current Response Level Maximum CY Direct Method (Bobber 2.14.1) Impedance Method (Bobber 2.14.2) y (Bobber 2.15)		Currently Capable?	
Transmi Transmi Transmi Source Efficience	Calibration It Voltage Response It Current Response Level Maximum Direct Method (Bobber 2.14.1) Impedance Method (Bobber 2.14.2) (Bobber 2.15) al Impedance / Admittance		Currently Capable?	
Transmi Transmi Transmi Source Efficience	it Voltage Response It Current Response It Current Response Level Maximum Or Direct Method (Bobber 2.14.1) impedance Method (Bobber 2.14.2) (Bobber 2.15) di Impedance / Admittance Impedance / Impedan		Currently Capable?	
Transmi Transmi Transmi Source Efficience	It Voltage Response It Current Response Level Maximum V Direct Method (Bobber 2.14.1) Impedance Method (Bobber 2.14.2) Impedance Method (Bobber 2.14.2) Id Impedance / Admittance Ity Patterns [Far Field]		Currently Capable?	
Transmi Transmi Transmi Source Efficience	it Voltage Response It Current Response It Current Response Level Maximum Or Direct Method (Bobber 2.14.1) impedance Method (Bobber 2.14.2) (Bobber 2.15) di Impedance / Admittance Impedance / Impedan		Currently Capable?	
Transmi Transmi Transmi Source Efficience	It Voltage Response it Current Response it Current Response Level Maximum Sy Direct Method (Bobber 2.14.1) Impedance Method (Bobber 2.14.2) al Impedance I Admittance Iy Patterns Far Field Near Field		Currently Capable?	

Transmit Voltage Response
Transmit Current Response
Source Level Maximum
Efficiency
Direct Method (Bobber 2.14.1)
Impedance Method (Bobber 2.14.2)
Impedance Method (Bobber 2.14.2)
Impedance Method (Bobber 2.14.2)
Impedance Admittance
Directivity Patterns
B.
Rear Field
Uniform Radiator
Non-uniform Radiator
Directivity Pactor / Index
Directivity

Physics-based calibration from first principles on devices using an approved method. Comparative measurements from to the device to those taken simultaneously from a device certified by the U.S. Navy or other U.S. Government entity.

Section 5h Capability to Calibrate Specific Underwater Acoustic Transducers and Transducer Arrays

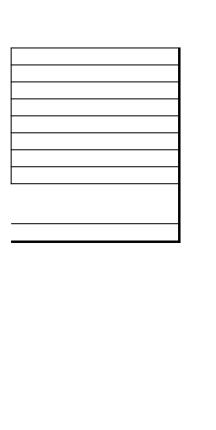
By type of application, indicate whether your company/organization can test and/or calibrate underwater acoustic transducers in accordanc specifications discussed in Section 5. For each device/system, state whether your company/organization plans to retain this capability thro this capability by 2015.

this capability by 2015.						
	Capability/Maintenance of Capability Through 2015 Capability Maintenance Capability by Type of Application					
Acoustic Receivers						
Reference Standard Hydrophones (Primary Calibration)						
Hydrophones (Secondary Calibration)						
Hydrophone Arrays						
Line Array						
Planar Array						
Cylindrical Array						
Spherical Array						
Other Array						
Acoustic Vector Field Sensors						
Acoustic particle displacement						
Acoustic particle velocity						
Acoustic particle acceleration						
Pressure gradient sensor						
Seismic Accelerometer Sensor						
Seismic Velocity / Geophone Sensor						
Vector Field Array						
Line Array						
Planar Array						
Other Array						
Hybrid Sensors (e.g. ocean bottom seismometer with hydrophone)						
Acoustic Projectors						
Piezoelectric Ceramic Projectors						
Flextensional Projector						
Slotted Cylinder Projector						
Moving Coll Projector						
Impulsive \$ources						

Δ

Air Gun				
Combustive Sound Sou	rce			
Projector Arrays				
Line Array / Seismic stre	eamer			
Planar Array				
Cylindrical Array				
Spherical Array				
Other Array				
Comments:				
•	BUSINESS CONFIDI	ENTIAL - Per Section 705	o(d) of the Defense Produ	uction Act

e with any of the technical ugh 2015, or will develop For "Will Lose Capability" Responses - Select one or more Explanations



2.	ection 6.a		Transc	lucer/Sub-Assembly Mar	sufacturing Stone				
St									
	State whether your company 1) is capable of performance 2015, and 3) identify the company's three most imp	orming each of the followir fortant non-U.S. facilities.	ng transducer manufacturi	ng steps at U.S-based and	I/or non-U.S. based faciliti	es it owns and/or operates	, 2) indicate whether it pla	ans to retain each identified	d capability through
	Manufacturing Steps	Company-Controlled U.SBased Capability	Retain Through 2015?	Number of U.Sbased employees experienced in this process	Company-Controlled Non-U.S. Based Capability	Retain Through 2015?	Non-U.S. Company Fa	cilities - Top Three Countri	es By Production (\$\$\$)
	Formulation and firing of piezoceramic materials			iii tiis process	Саравінту				
	Application of electrodes on piezoceramics								
	Polarization of piezoceramic materials								
	·								
	Determination of piezoelectric properties in piezoceramics (including d-constants, k electromechanical coupling, elastic properties or								
	frequency constants, dielectric properties, etc).								
	Growth of piezocrystal materials								
	Application of electrodes on piezocrystals								
Α	Testing of electrode adhesion in piezocrystals								
	Polarization of piezocrystal materials								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc).								
	Bonding of similar and dissimilar materials								
	Hermetic Sealing of Pressure Vessels								
	Integrated electronics								
	Magnetics design (tuning and matching circuits)								
	Miniature Electronics Assembly								
	Transducer build								
	Potting for submerged use								
	Testing of handling requirements								
	Telemetry wiring								
	Calibration								
\vdash				L					
_	Report the number of U.Sbased and/or non-U.S. or remain the same through 2015.	·	npany uses to perform ea					sed and Non-U.S. vendors	will increase, decrease,
В	Manufacturing Steps	Utilize U.SBased Vendor?	Change Through 2015	Utilize Non-U.S. Based Vendor?	Non-U.S. Based Vendo	ors - Top Three Countries E 2	3 3 2011 Purchases (\$\$\$)	% Change Through 2015	
	Formulation and firing of piezoceramic materials								
	Application of electrodes on piezoceramics								
	Polarization of piezoceramic materials								
	Determination of piezoelectric properties in piezoceramics (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc).								
	Growth of piezocrystal materials								
	Application of electrodes on piezocrystals			1					
	Testing of electrode adhesion in piezocrystals								
	Polarization of Diezocrystal materials								
	Polarization of piezocrystal materials Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc).								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels Integrated electronics								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels Integrated electronics Magnetics design (funing and matching circuits)								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels Integrated electronics Magnetics design (tuning and matching circuits) Miniature Electronics Assembly								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels Integrated electronics Magnetics design (tuning and matching circuits) Miniature Electronics Assembly Transducer build								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels Integrated electronics Magnetics design (tuning and matching circuits) Miniature Electronics Assembly Transducer build Potting for submerged use								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels Integrated electronics Magnetics design (funing and matching circuits) Miniature Electronics Assembly Transducer build Potting for submerged use Testing of handling requirements								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels Integrated electronics Magnetics design (tuning and matching circuits) Miniature Electronics Assembly Transducer build Potting for submerged use Testing of handling requirements Telemetry wiring								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels Integrated electronics Magnetics design (funing and matching circuits) Miniature Electronics Assembly Transducer build Potting for submerged use Testing of handling requirements								
	Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels Integrated electronics Magnetics design (tuning and matching circuits) Miniature Electronics Assembly Transducer build Potting for submerged use Testing of handling requirements Telemetry wiring								

C.3 Are Navy calibrations facities required and utilized to support these tests?		Comment:			
Describe what unique tools/machinery (large 4-axis milling machines, large ovens, etc) you utilize D. in the production of transducers or transducer systems. Indicate any issues with availability of these tools/machinery.					
If large systems are developed, how are these transported to customers? Indicate any issues with transportation scheduling.					
Comments:					
BUSINESS CONFIDENTIAL - Per Section 705(d) of the Defense Production Act					

and an Ch	B	And and Chandands				
ection 6.b		trol and Standards		. Fan anala indianta ud		al atamala valaa.a
Specify the types of process controls and standard defined.	s your company applies to	each of the following tra	nsducer manuracturing step	s. For each, indicate w	nen the last set of controls an	id standards were
	Process Controls	Last Updated	Standards Applied	Last Updated	Other Process Controls Applied (specify)	Last Updated
Formulation and firing of piezoceramic materials						
Application of electrodes on piezoceramics						
Polarization of piezoceramic materials						
Determination of piezoelectric properties in piezoceramics (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc).						
Growth of piezocrystal materials						
Application of electrodes on piezocrystals						
Testing of electrode adhesion in piezocrystals						
A. Polarization of piezocrystal materials						
Determination of piezoelectric properties in piezocrystals (including d-constants, k electromechanical coupling, elastic properties or frequency constants, dielectric properties, etc). Bonding of similar and dissimilar materials Hermetic Sealing of Pressure Vessels Integrated electronics Magnetics design (tuning and matching circuits) Miniature Electronics Assembly Transducer build Potting for submerged use Testing of handling requirements Telemetry wiring Calibration						
3. Describe how your company insures that it is meeti	ng Navy standards and rep	eatability.				
Comments:						
	BUSINESS CONF	IDENTIAL - Per Section	n 705(d) of the Defense Pro	oduction Act		

Sec	tion		en fecilities managed h	Current	Testing/Ca	libration Fa	cilities - La			
	Plea	Please identify and describe the lake and/or ocean facilities managed by your company/organization.								
						Physical Dimensions				
		Name of Facility	Street Address	City	State	Usable Length	Usable Width			
A.	1.									
	2.									
	3.									
	4.									
	5.									
	6.									
	7.									
	8.									
	9.									
	10.	Comments:								
		Comments.			-		-			
		Name of Facility	Type of Facility	Critical Updates						
	1.									
	2.									
	3.									
В.	4. 5.									
	6.									
	7.									
	8.									
	9.									
	10.									
		Comments:			•					
		•		BUSI	NESS CON	IFIDENTIAL	Per Sect			

(Meters)						
Usable Depth	Usable Frequency Range (in Hz)	Appropriate for Individual Sensor Testing/Calibration?	Appropriate for Full- Scale System Testing/Calibration?	Number of Technical Support Staff Assigned to Facility	Status of Facility Infrastructure	Challenges to Maintaining this Facility
Recomm	ended Updates					

.d				Capabilities	of Enviromentally	Controlled Fa
	Plea	se provide information about environme	ntally controlled facilities m			
		·	ĺ		, ,	Physical
		Name of Facility	Street Address	City	State	Usable
		•				Length
	1.					
	2.					
	3.					
١.	4.					
	5.					
	6.					
	7.					
	8.					
	9.					
	10.					
					·	
		Name of Facility	Environmental Para	meters Controlled		
	1.		Ambient Pressure			
	2.		Attenuation			
	3.		Bulk Modulous			
3.	4.		Density			
ο.	5.		Salinity			
	6.		Shear Speed			
	7.		Sound Speed			
	8.		Temperature			
	9.		Other (Describe below)			
	10.		Other (Describe below)			

cilities							
Dimensions (Meters) Usable Width Usable Depth		Usable Frequency Range (in Hz)	Appropriate for Individual Sensor Testing/Calibration?	Appropriate for Full- Scale System Testing/Calibration?	Number of Technical Support Staff Assigned to Facility	Status of Facility Infrastructure	
	Crit	ical Updates		Recommended Updates			
Per Section	1 705(d) of	the Defense Prod	uction Act				

Challenges to Maintaining this Facility
-

Sec	tion 7	Outso	urcing
	Identify the primary reasons listed on the previous page (ources to Non-U.S. entities one or more of the transducer manufacturing steps
	No U.S. capability		
	No U.S. contractor found		
	Insufficient U.S. workforce		
	Foreign government subsidi	es - direct	
Α.	Foreign government subsidi	es - indirect	
Α.	Lack of tax/financial incentives to product in U.S.		
	Lower costs		
	To assure better market acc	ess	
	Competitive pricing pressure	es	
	Maximize profits		
	To better serve offshore mai	rkets	
	Other (specify)		
	Comments:		
	BUS	INESS CONFIDENTIAL -	Per Section 705(d) of the Defense Production Act
•		<u> </u>	

		Q		
Sec	tion 8 Describe the actions your company	Competition has taken in the last five	veness	
	years to improve its competitiveness			
	Comment:			
	Describe the actions your company its competitiveness over the next five			
	Comment:			
^	Is your company aware of the Navy's	s Sonar Transducer Relabi	ility Improvement Program (STRIP) investments?	
C.	Does your company hold any of the STRIP program?	documentation, or otherwi	se have access to that documentation, from the	
D.	Are there any changes to U.S. Gove competitiveness? Explain below.	rnment policies and/or reg	julations that would increase your company's	
	Comment:			
	Based on your highest unit ordered year to maintain the manufacturing o	product for the U.S. Nav capability (personnel and in	yy in 2011, how many units must you produce per nfrastructure)?	
	Comment:			
E.	What is the cost to maintain this prod	cess?		
	Comment:			
	If this product requirement went awa below.	y, what would be the cost	to re-initiate the process in the future? Explain	
	Comment:			
	Based on your lowest unit ordered year to maintain manufacturing capa		y in 2011, how many units must you produce per structure)?	
F.	What is the cost to maintain this profuture? Explain below.	cess? If this product requi	rement went away, what would be the cost to re-initi	ate the process in the
	Comments:			
	RHSINES	S CONFIDENTIAL - Per S	Section 705(d) of the Defense Production Act	
	503114E3	2 22.11 IDENTIFIE FULU	roomon rooma ror mic belefied i roumellell Act	

	on 9.a	Financial Perf						
Report select line items from your company's financial statement for years 2008-2012. From the drop-down indicate whether the reported income statement and palance sheet select line items are Business Unit/Division or Corporate/Whole Company financials.								
Vloto.	Business Unit/Division financials are preferr	Pad						
	Calendar year data is preferred.	eu.						
	Source of Financial Line Item	IS:						
	Reporting Schedule:							
	·		Record in \$ Thou	sands, e.g. \$12,000.00 =	survey input of \$12			
Income Statement (Select Line Items)		2008	2009	2010	2011	2012 Estimated		
	let Sales (and other revenue)							
B. E	Earnings Before Interest and Taxes							
C. N	let Income							
Balance Sheet (Select Line Items)		Record in \$ Thousands, e.g. \$12,000.00 = survey input of \$12						
		2008	2009	2010	2011	2012 Estimated		
A. lı	nventories							
В. С	Cost of Goods Sold							
C. F	Retained Earnings							
D. T	otal Current Assets							
	otal Assets							
	otal Current Liabilities							
G. T	otal Liabilities							
H. T	otal Owner's Equity							
	Comments:							
	BUSINE	SS CONFIDENTIAL -	Per Section 705(d) o	f the Defense Production	n Act			

	: O I							
Use	Financial Health Use the space below to qualify with narrative any anomalies, transactions, or non-recurring events reflected in your financial statement line items, e.g. reporting restatement, merger and acquisition, chapter 11, SEC investigation, etc.							
A.	2008							
B.	2009							
C.	2010							
D.	2011							
E.	2012							
Comments:								
BUSINESS CONFIDENTIAL - Per Section 705(d) of the Defense Production Act								

Section 10

Research and Development

State your company's: 1) total (internal and external funded) research and development (R&D) dollar expenditures, 2) the type of R&D performed by percent allocation, 3) and the percentage of total R&D expenditures relating exclusively to underwater transducer and sonar system business lines, and 4) your company's R&D funding sources by percent of total R&D dollars sources.

Note: If your company's annual Total R&D Expenditures and Total R&D Funding Sources do not match, explain the discrepancy in the space provided. Note: Calendar year data is preferred.

		Source of R&D Data:							
	R&D Reporting Schedule:								
		R&D Expenditures	Record \$ in Thousands, e.g. \$12,000.00 = survey input of \$12						
		R&D Experialtures	2008	2009	2010	2011	2012 Estimated		
	1.	Total R&D Expenditures							
	2.	Basic Research (as a percent of Line 1)							
Α.	3.	Applied Research (as a percent of Line 1)							
	4.	Product/Process Development (as a percent of Line 1)							
	5.	Total (must equal 100%)	0%	0%	0%	0%	0%		
		% of Line 1 Related to Underwater Transducers							
	7.	% of Line 1 Related tφ Underwater Sonar Systems							
		R&D Funding Sources		Record \$ in Thousands, e.g. \$12,000.00 = survey input of \$12					
		· ·	2008	2009	2010	2011	2012 Estimated		
	1.	Total R&D Funding Sources							
	2.	Internal/Self-Funded/IRAD (as a percent of Line 1)							
	3.	Total Federal Government (as a percent of Line 1)							
	4.	Federal funding from SBIR/STTR program (as a percent of Line 1)							
В.	5.	Total State and Local Government (as a percent of Line 1)							
	6.	Universities - Public and Private (as a percent of Line 1)							
	7. U.S. industry, venture capital, non-profit (as a percent of Line 1)								
	8.	Non-U.S. investors (as a percent of Line 1)							
	9.	Other (specify)							
		% of Line 1 Related to Underwater Transducers							
	11.	% of Line 1 Related to Underwater Sonar Systems							
		Comments:							
		BUSINESS CONFIDENTIAL - F	Per Section 705(d)) of the Defense Pro	duction Act				

Sec	ction 11.a	Employment					
	te the number of annual, full-time equivalent (FTE) employee		tions by labor type fo	r vears 2008-2011. D	o not double count p	ersonnel who perforn	n cross-operational roles.
	, , , , , , , , , , , , , , , , , , ,	. ,		,			
Not	e: "Total in U.S. Operations" should comprise all preceding la	abor categories. If n	ot, please indicate w	hy in the comment box	⟨.		
	Source of Operational Data:						
	Reporting Schedule:						
	Professional Occupations	2008	2009	2010	2011	2012	Current % U.S. Citizens
	Administrative Staff						
	Production Managers/Supervisors/Executives						
	Research and Development (R&D) Staff						
	4. Production Line Workers, Support Technicians						
	5. Quality Control, Test Operations						
	6. Sales and Marketing						
Α.	7. Facility Operations, Maintenance						
	8. IT/Network Engineers						
	9. Other (specify)						
	10. Other (specify)						
	Total in U.S. Operations						
	Percentage of full-time equivalent staff engaged in Underwater Transducer and/or Sonar Systems	%	%	%	%	%	
	Total Number of Scientists and Engineers						
В.	Percentage of FTE Scientists and Engineers Engaged in Underwater Transducer and/or Sonar Systems						
	Comments:	<u> </u>	1	_1	I	1	1
	Comments.						

_											
Co	ction 11.b			mployment (cont.)							
	scribe the size of your engineering workforce, the	nature of their expe		· · · · · · · · · · · · · · · · · · ·	ience, and the portior	n of the workforce tha	t are U.S. citizens:				
			Applicable Working Experience								
		> 20 `		10 - 20 Years		5 - 10 Years		< 5 Years			
		# of Employees	% U.S. Citizens	# of Employees	% U.S. Citizens	# of Employees	% U.S. Citizens	# of Employees	% U.S. Citizens		
	Total technical personnel										
	Experience in piezo-ceramic formulation and process control										
	Experience in piezo-crystal formulation and process control										
	Experience in application of material/element design to systems that primarily operate below 1 kHz										
	Experience in application of material/element design to systems that primarily operate between 1 kHz - 10 kHz										
A.	Experience in application of material/element design to systems that primarily operate between 10 kHz - 100 kHz										
	Experience in application of material/element design to systems that primarily operate above 100 kHz										
	Experience with electro-dynamic actuators and force drivers										
	Experience in bonding of materials										
	Experience in potting, encapsulation, or filling (under vacuum) of transducers										
	Experience with creating cost-effective, in- process testing capabilities										
	Comments:										

Sect	ection 11.c Employment (cont.) Difficult to Hire Difficult to Retain									
A.		ne drop-down list of professional occupations, indicate what categories of nel are the most difficult to hire and retain. Explain below								
В.	Identify your company's critical personnel skills and competencies, i.e. expertise that is critical to your company's viability and long-term competitiveness. 1.									
C.	Indicate the top five universities from which your technical personnel received their terminal degrees (the first university listed should be the one where the most personnel attended). 1.									
D.	Indicate the distribution (percentages) of your technical personnel's highest education levels.	Technical Training	Bachelors Degree	Masters Degree	Ph.D.					
	Indicate % U.S. Citizens									
E.	Does your company have a piezoelectric ceramist on staff? If "Yes," indicate the highest level of academic degree of these individuals. Yes/No Highest Degree Level									
F.	Does your company have a piezoelectric materials formulator on staff? If "Yes," indicate the highest level of academic degree of these individuals.									
G.	What percentage of your technical personnel are expected to retire (or leave their jobs) within the next five years?									
Н.	What percentage of your technical personnel are expected to be new hires over the next five years?									
I.	What percentage of your technical personnel are expected to pursue higher education over the next five years?									
	What percentage of your technical personnel were hired with necessary basic skills from previous education?									
J.	What were the primary skills that had to be taught on-the-job?									
	Comments:									
	RUSINESS CONFIDENTIAL - Per Section 705(d) of the Defense Production Act									

Section 12	Certification							
	upplied in response to this questionnaire is complete and correct to the best of							
his/her knowledge. It is a criminal offense to willfully make a false statement or representation to any department or agency of the United								
States Government as to any matter within its jurisdiction	on (18 U.S.C.A. 1001 (1984 & SUPP. 1197))							
Company Name								
Company's Internet Address								
Name of Authorizing Official								
Title of Authorizing Official								
E-mail Address								
Phone Number and Extension								
Date Certified								
If POC is different from the above named, include below	W:							
Point of Contact Name								
Title of Point of Contact								
E-mail Address								
Phone Number and Extension								
Would you like a free copy of the final report?								
In the box below, please provide any additional comme	ents or any other information you wish to include regarding this assessment.							
How many hours did it take to complete this survey?								
BUSINESS CONFIDENTIAL - Per Section 705(d) of the Defense Production Act								